



(ESL)² = (SSL)(EEL)

The Electrochemical Society (ECS) has a long history of archival technical publishing, beginning in 1902 when the Society was formed, wherein a record of the papers presented at Society meetings was published as *Transactions of the American Electrochemical Society*. ECS has published articles in both electrochemical and solid state science and technology in one full-papers journal, *Journal of The Electrochemical Society* (JES), since 1948. In 2002, the letters section of JES was extracted and a separate letters journal, *Electrochemical and Solid State Letters* (ESL), was introduced. After fourteen years of existence, ESL reached the age of retirement but has been reincarnated into two letters journals, *ECS Solid State Letters* (SSL) and *ECS Electrochemistry Letters* (EEL). This issue marks the launch of SSL and EEL. Separation of ECS journals into electrochemical and solid state segments was instituted to better serve our authors, readers and the scientific and engineering communities, by making available individual journals that focus on the two general technical areas represented by ECS. I am serving as the editor of SSL and EEL is edited by Petr Vanýsek.

In order to facilitate and shorten the review and publication cycle and to ensure effective coverage of the topical technical areas of SSL, an expanded and separate Editorial Board has been established for SSL and *ECS Journal of Solid State Science and Technology* (JSS). SSL and JSS are letter and full-paper journals, respectively, that cover the solid state focus areas for ECS journals. Specifically, the technical interest areas (TIAs) that describe the scope of ECS journals and the Technical Editors who oversee the evaluation of manuscripts submitted in these TIAs are: Electronic Materials and Processing (Jennifer Bardwell), Dielectric Science and Materials (Stefan DeGendt), Carbon Nanostructures and Devices (Francis D'Souza), Electronic and Photonic Devices and Systems (Yue Kuo), Luminescence and Display Materials, Devices and Processing (Kailash Mishra) and Physical Sensors (Rangachary Mukundan). We continue to utilize the expertise of our Editorial Advisory Committee to rapidly assess manuscripts and offer insightful feedback to authors and editors. More details regarding the restructuring of ECS journals can be found in the spring, 2012 issue of *Interface*, beginning on p. 18.

The launching of new journals is a gargantuan task that would not have been possible without the dedication and extensive work of a large number of people. First, the ECS Technical Interest Areas Task Force, chaired by Bill Brown, put in countless hours to ensure that the technical scope and focus of our (now) four journals are appropriate for current and future directions of the Society. Task Force efforts were coordinated and assisted enormously by several ECS Headquarters staff members. In particular, Mary Yess, ECS Deputy Executive Director and Publisher, Ann Goedkoop, ECS Director of Publications, and Paul Cooper, ECS Editorial Manager, directed and implemented the numerous changes that ECS journals have undergone over the past year; without their tireless efforts, this publishing transformation would not have been possible, especially over a very short period of time.

As we begin this new phase for ECS journals, I want to thank the many authors, reviewers and readers for their diligence and hard work to ensure quality publications. We look forward to your continued support and advice as we undertake our new responsibilities for four journals. We also seek your input regarding how we can continue to improve the quality, timeliness and significance of ECS solid state journals. Please contact me at dennis.hess@chbe.gatech.edu with your suggestions and comments. Thanks for taking part in and contributing to the new ECS journals and the future of the Society.



Dennis W. Hess
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